



Attorney's Docket No.: 10417-103002 / F51-139075M/SW

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Eiji Nishibe et al.

Art Unit : 2812

Serial No. : 10/809,011

Examiner : Walter Lee Lindsay, Jr.

Filed : March 25, 2004

Title : MANUFACTURING METHOD FOR A SEMICONDUCTOR DEVICE WITH
REDUCED LOCAL CURRENT

Mail Stop Amendment

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF MARCH 23, 2006

Please amend the above-identified application as follows:

CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

June 23, 2006

Date of Deposit

Signature

Roselynn Scarfo

Roselynn Scarfo

Typed or Printed Name of Person Signing Certificate